

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of ) **MAIL STOP AFTER FINAL**  
Jung-hyun Lee et al. )  
Application No.: 10/797,046 ) Group Art Unit: 2811  
Filed: March 11, 2004 ) Examiner: Ori NADAV  
For: METHOD FOR MANUFACTURING ) Confirmation No.: 4688  
OXIDE FILM HAVING HIGH )  
DIELECTRIC CONSTANT, )  
CAPACITOR HAVING DIELECTRIC )  
FILM FORMED USING THE )  
METHOD, AND METHOD FOR )  
MANUFACTURING THE SAME )

**RESPONSE UNDER 37 C.F.R. § 1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In complete response to the final Office Action dated October 22, 2008,  
Applicants submit herewith a petition for one month extension of time extending the  
period for response from January 22, 2009 to February 22, 2009 and the following  
Amendments and Remarks.

**Amendments to the Claims** are reflected in the Listing of Claims which  
begins on page 2 of this Response.

**Remarks** begin on page 3 of this Response.

DO NOT ENTER: /O.N./